

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Satoshi Hayashi et al.

Serial No.: 10/581,578

Filed: December 26, 2006

For: ANION ADSORBING CARBON
MATERIAL, AS WELL AS
MANUFACTURING METHOD AND
MANUFACTURING FACILITIES FOR
SAME

Patent Examiner: Walck, Brian D.

Group Art Unit: 4181

December 22, 2008

Costa Mesa, California 92626

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sirs:

In response to the Restriction Requirement of November 20, 2008, please enter the following: